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## APPLICANTS

Shinichi Ito, Kanagawa-ken, JAPAN;

Riichiro Takahashi, Kanagawa-ken, JAPAN;  
Tatsuhiko Ema, Kanagawa-ken, JAPAN; Katsuya Okamura, Kanagawa-ken, JAPAN;

## \*\* CONTINUING DATA

*MK (verified)*  
 This application is a DIV of 10/396,407 03/26/2003 PAT 6,709,531  
 which is a DIV of 09/784,200 02/16/2001 PAT 6,579,382

## \*\* FOREIGN APPLICATIONS

*MK (verified)*  
 JAPAN P2000-39683 02/17/2000  
 JAPAN P2000-297441 09/28/2000

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	DRAWING 18	CLAIMS 20	CLAIMS 2
Verified and Acknowledged	<i>curry</i> <i>MK</i> Examiner's Signature Initials				

## ADDRESS

22852  
 FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER  
 LLP  
 901 NEW YORK AVENUE, NW  
 WASHINGTON, DC  
 20001-4413

## TITLE

Chemical liquid processing apparatus for processing a substrate and the method thereof

All Fees